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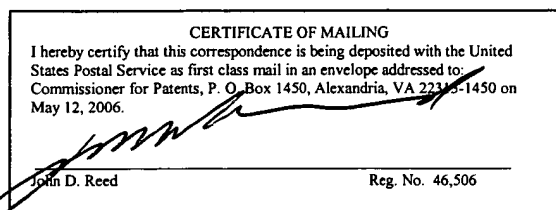
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant(s) : Todd Edgar
Serial No. : 10/044,178
Filed : January 10, 2002
Title : SEMICONDUCTOR DEVICE INCORPORATING AN ELECTRICAL
CONTACT TO AN INTERNAL CONDUCTIVE LAYER AND METHOD
FOR MAKING THE SAME
Docket : MIO 0011 N2
Examiner : Thao Le
Art Unit : 2814

MAIL STOP AF
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:



RESPONSE UNDER 37 CFR 1.116

This response is being filed in response to an Office Action mailed February 14, 2006, having a reply due date of May 14, 2006. Reconsideration is respectfully requested in light of the amendments and remarks below.

Amendment to the Claims begins on page 2.

Remarks begin on page 8.